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## BIB DATA SHEET

CONFIRMATION NO. 3115

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/591,723	01/08/2007	438	2823	FUJI:397		
<b>APPLICANTS</b> Kozo Fujimoto, Hyogo, JAPAN; Hirohiko Watanabe, Tokyo, JAPAN; Kazutaka Ikemi, Ibaraki, JAPAN; Keiichi Matsumura, Tokyo, JAPAN; Masayoshi Shimoda, Tokyo, JAPAN; Katsumi Taniguchi, Kanagawa, JAPAN; Tomoaki Goto, Nagano, JAPAN;						
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/02538 03/02/2004						
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-254951 08/30/2002 JAPAN 2003-298057 08/22/2003						
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 05/12/2007						
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b>	<b>SHEETS DRAWINGS</b>	<b>TOTAL CLAIMS</b>	<b>INDEPENDENT CLAIMS</b>
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		JAPAN	3	16	4
Verified and	/WILLIAM M BREWSTER/ Examiner's Signature		Initials			
<b>ADDRESS</b> ROSSI, KIMMS & McDOWELL LLP. 20609 Gordon Park Square, Suite 150 Ashburn, VA 20147 UNITED STATES						
<b>TITLE</b> Manufacturing method of semiconductor module including solid-liquid diffusion joining steps						
<b>FILING FEE RECEIVED</b> 3402	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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